



TS97-510BC

serial no. 09/729,154

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

SUBJECT: Serial #: 09/729,154  
File Date: Dec. 4, 2000  
Inventor: Chen-Hua Yu and Syun-Ming Jang  
Examiner: Ron Pompey  
Art Unit: 2812  
Title: A SHALLOW TRENCH ISOLATION PROCESS FOR  
REDUCED JUNCTION LEAKAGE

#15-  
Declaration  
J. McMillen  
3/28/03  
RECEIVED  
MAR 24 2000  
TECHNOLOGY CENTER 2800

DECLARATION UNDER 37 CFR 1.131

Honorable Commissioner of Patents & Trademarks

Washington, D.C. 20231

Sir:

I, Chen-Hua Yu and Syun-Ming Jang, hereby state:

1. I am a co-inventor of Claims 23-33 of the above-identified patent application.
2. Prior to October 21, 1998, we conceived of the idea for A Shallow Trench Isolation Process For Reduced Junction Leakage, as described and claimed in our application, and a copy of the invention disclosure describing our invention entered the United States of America before October 21, 1998.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States

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Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

*Chen-Hua Yu* 3/11/03  
Chen-Hua Yu Date

*Syun-Ming Jang* 3/11/03  
Syun-Ming Jang Date